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NO. 4312 P. 3/14

DEC 08 2005

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Venkat Selvamanickam, et al.

Title: APPARATUS FOR AND METHOD OF CONTINUOUS HTS TAPE  
BUFFER LAYER DEPOSITION USING LARGE SCALE ION BEAM  
ASSISTED DEPOSITION

App. No.: 10/609,250

Filed: June 26, 2003

Examiner: Ram N. Kackar

Group Art Unit: 1763

Customer No.: 34456

Confirmation No.: 7760

Atty. Dkt. No.: 1014-SP101-US

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**MS AMENDMENT**

Commissioner for Patents

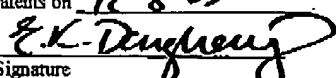
PO Box 1450

Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION**

Dear Sir:

In response to the Office Action mailed September 8, 2005, please amend the above-identified application as follows:

CERTIFICATE OF TRANSMISSION/MAILING	
I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to the Commissioner for Patents on <u>12-8-05</u>	
Elise K. Dougherty	
Typed or Printed Name	Signature